

**Notice of References Cited**

Application/Control No.

09/344,826

Applicant(s)/Patent Under  
Reexamination  
CHEN ET AL.

Examiner

Stephen M Brinich

Art Unit

2624

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,543,941	08-1996	Parker et al.	358/534
	B	US-2002/0080098	06-2002	Kim, Min Chul	345/60
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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